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Application Serial No. 10/678,513
Response to October 19, 2004 OA

MI22-2391

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Brook Kebede
Attorney's Docket No. MI22-2391
Title: Semiconductor Processing Methods Of Forming A Contact Opening To A
Conductive Line and Methods of Forming Substrate Active Area
Source/Drain Regions

RESPONSE TO OCTOBER 19, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
Tel. 509-624-4276; Fax 509-838-3424
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3817

Responsive to the Office Action dated October 19, 2004, Applicant amends
and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.